	Application No.	Applicant(s)
Examiner-Initiated Interview Summary	10/571,426	MORI ET AL.
	Examiner	**Art Unit**	
	Joseph C. Nicely	2813	

All Participants:

Status of Application: _Allowable_

(1) _Joseph C. Nicely_.

(3) _____.

(2) _Takashi Saito (L0123)_.

(4) _____.

Date of Interview: _7 January 2010_

Time: _11:30 a.m._

Type of Interview:
☒ Telephonic
☐ Video Conference
☐ Personal (Copy given to: ☐ Applicant   ☐ Applicant's representative)

Exhibit Shown or Demonstrated: ☐ Yes   ☒ No
   If Yes, provide a brief description: .

Part I.

Rejection(s) discussed:
_N/A_

Claims discussed:
1 and 15

Prior art documents discussed:
Yoshiko (JP 2004-039832)

Part II.

SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED:
See Continuation Sheet

Part III.

☒ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.

☐ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.

/Joseph C. Nicely/
Examiner, Art Unit 2813

(Applicant/Applicant's Representative Signature – if appropriate)

 Continuation of Substance of Interview including description of the general nature of what was discussed: Examiner contacted applicant's representative, Takashi Saito, on December 29, 2009 to discuss further clarifying that the second silicon layer is in physical contact with the first semiconductor layer in order to distinguish the claimed device from the device shown in Yoshiko. On January 6, 2010, applicant's representative gave permission for the clarification to be made in an Examiner's Amendment. On January 7, 2010, Examiner contacted applicant's representative to get permission to clarify which claim 15 depends from. Clarification was provided and the proper dependency will be detailed in the Examiner's Amendment..